10/707,878 FIS920030317US1

## In the United States Patent and Trademark Office

Date:

**HEREWITH** 

In re

Ashima Chakravarti, et al.

Filed:

1/20/04

Application of:

For:

Polycrystalline Silicon Layer With Nano-Grain

Structure And Method of Manufacture

**Serial Number:** 10/707,878

Confirmation No.

1877

Art Unit:

2891

Examiner:

SMITH, BRADLEY

## **RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT (37 CFR 1.121)**

Hon. Commissioner of Patents and Trademarks P. O. Box 1450 Alexandria, VA 23313-1450

Dear Sir:

In response to the Notice of Non-Compliant Amendment (37 CFR 1.121), Applicants are hereby submitting new claims pages with a complete listing of all of the claims. These claims pages should be substituted for the claims pages submitted with the last amendment.

10/707,878 FIS920030317US1

Further action with respect to the present application is earnestly solicited.

Respectfully Submitted, Ashima Chakravarti, et al.

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